Date:

Application for Use of Ultra-High Voltage Electron Microscope Laboratory (for External Use)

To Director of the Ultra-High Voltage Electron Microscope Laboratory EcoTopia Science Institute at Nagoya University

Applicant:		
Located at:		
Name of Corporation:		
		(Signature)
Name:		_(
Title:		
Contact:		
TEL:	FAX:	
E-Mail:		

An application is hereby made as specified below to use the Ultra-High Voltage Electron Microscope Laboratory of EcoTopia Science Institute at Nagoya University, with full acceptance of the Terms and Condition of Use of the Laboratory.

Details of Application

Title of the research:		
Check the electron microscope(s) you wish to use (multiple selection is possible): ☐ Ultra-high voltage electron microscope H-1250ST, 1000kV ☐ 3D electron microscope TECNAI, 300kV ☐ Analytical electron microscope H-9000, 300kV ☐ Field emission electron microscope HF-2000, 200kV ☐ General-purpose electron microscope H-800, 200kV		
Period of use: From (day) (month) (year) to (day) (month) (year)		
Number of times to operate microscope:		
Purpose of use and details of use:		
Type of sample: □ Living organism □ Metal □ Ceramic □ Semiconductor □ Organic material □ Others ()		
Shape and characteristics of sample: (Specify components and size of sample, and whether or not sample is hazardous.)		
Area of consultation sought: Image analysis Diffraction pattern interpretation Image simulation Others ())		
Do you request analysis consultation?		
Indicate your requests regarding the publication of research results, obtainment of patents, etc.		

Attach a document (in a form of applicant's choice) detailing the name, affiliation, title, and degree of experience in electron microscope use of each participating researcher (*).

^{*} Degree of experience in using electron microscopes: mark "(a)" for having experience including special operation of analytical electron microscopes; mark "(b)" for having experience in simple operation; and mark "(c)" for having little experience.